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To All Concerned

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President
(Securities code: 6235 Tokyo Stock Exchange,
1st Section)
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Completion of Double-sided Sputtering Coater

We are pleased to announce that we have completed the development of a new type of sputtering coater (OWLS -1800D) capable of double-sided film deposition.

A unique feature of this system is that it is capable of depositing film on substrates facing upward, downward, or on both sides simultaneously, allowing a flexible response to customers' film deposition needs with a single coater.

When depositing film on both sides of wafers with conventional coaters, it was necessary to deposit film on one side, before flipping the wafer over to deposit film on the other side. This coater is an improved version of our previously developed horizontal sputtering coater, and is now capable of double-sided film deposition. This capability has now made it possible to reduce deposition time. In addition, the ability to deposit film on both sides without exposing wafers to the atmosphere prevents contamination with dust and other contaminants, and delivers improved quality and yield, contributing to improved production efficiency for customers.

We expect this coater to be used for products such as automotive sensors, electronic components, and optical components.

We will continue to strive to develop new equipment and develop new markets.